

UNITED STATES DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

PATENT

In the application:

Inventors: HE, Ting et al.
Serial Number: 10/757,302
Filed: January 14, 2004

For: HIGH THROUGHPUT PHYSICAL VAPOR DEPOSITION SYSTEM
FOR MATERIAL COMBINATORIAL STUDIES

Group Art Unit: 1763
Examiner: Richard R. Bueker

Atty. Docket No.: 3994994-148069 CONFIRMATION NO. 4457

Amendment and Response to Office Action Mailed on June 25, 2010

By E-file [registered user] on SEPTEMBER 27, 2010
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Honorable Commissioner:

In response To the Office Action Mailed on June 25, 2010, entry of this amendment,
reexamination and reconsideration is requested.

1) Amendments to the Claims begin on page 2; and

3) Remarks begin on page 7.

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